OIPE JC10 AUG 04 2005 PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Roberto R. Panepucci et al.	Examiner:	Unknown
Serial No.:	10/781,339	Group Art Unit:	2874
Filed:	February 18, 2004	Docket:	1153.099US1
Title:	OPTICAL WAVEGUIDE DISPLACEMENT SENSOR		

INFORMATION DISCLOSURE STATEMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicant respectfully requests that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicant requests that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicant with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Information Disclosure Statement. However, if an Office Action on the merits has been mailed, the Commissioner is hereby authorized to charge the required fees to Deposit Account No. 19-0743 in order to have this Information Disclosure Statement considered.

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications are no longer required to be provided to the Office. Notification of this change was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004. Thus, Applicant has not included copies of any U.S. Patents or the Published Application cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

ROBERTO R. PANEPUCCI ET AL.

By their Representatives,

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Date 8-2-2005 By _____
Bradley A. Forrest
Reg. No. 30,837

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 2nd day of August, 2005.

JAMES KANYSIK
Name

Signature

PTO/SB/08A(10-01)
Approved for use through 10/31/2002. OMB 651-0031
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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)



Sheet 1 of 2

Complete if Known	
Application Number	10/781,339
Filing Date	February 18, 2004
First Named Inventor	Panepucci, Roberto
Group Art Unit	2874
Examiner Name	Unknown
Attorney Docket No:	1153.099US1

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-2003/0154771 A1	08/21/2003	de Charmoy, G. H., et al.	03/03/2003
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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No [1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
		"1.2.1 Contact AFM", A Practical Guide to Scanning Probe Microscopy, Chapter 1, Section 1.2.1, Thermo Microscopes website: http://www.topometrix.com/spmguide/1-2-1.htm, (Observed October 28, 2002), 3 pgs.	
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EXAMINER **DATE CONSIDERED**

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional) 2 Applicant is to place a check mark here if English language Translation is attached

PTO/SB/08A(10-01)
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US Patent & Trademark Office: U.S. DEPARTMENT OF COMMERCE
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Substitute for form 1449A/PTO **INFORMATION DISCLOSURE STATEMENT BY APPLICANT** *(Use as many sheets as necessary)*	*Complete if Known*	
	Application Number	10/781,339
	Filing Date	February 18, 2004
	First Named Inventor	Panepucci, Roberto
	Group Art Unit	2874
	Examiner Name	Unknown
Sheet 2 of 2	Attorney Docket No: 1153.099US1	

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	**Cite No [1]**	**Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.**	**T[2]**
		CARR, D. W., et al., "Measurement of Mechanical Resonance and Losses in Nanometer Scale Silicon Wires", Applied Physics Letters, 75(7), (1999), 920-922	
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EXAMINER **DATE CONSIDERED**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Roberto R. Panepucci et al.

Title: OPTICAL WAVEGUIDE DISPLACEMENT SENSOR

Docket No.: 1153.099US1
Filed: February 18, 2004
Examiner: Unknown



Serial No.: 10/781,339
Due Date: N/A
Group Art Unit: 2874

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

X A return postcard.
X An Information Disclosure Statement (2 pgs.), Form 1449 (2 pgs.), and copies of 22 cited documents.

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
Customer Number 21186

By: _____
Atty: Bradley A. Forrest
Reg. No. 30,837

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JAMES KANYUSIK
Name

Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
(GENERAL)